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APPLICANTS

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** CONTINUING DATA *****

yes K.N.

This application is a DIV of 10/080,108 02/21/2002 PAT 6,767,754

which is a DIV of 09/005,176 01/08/1998 PAT 6,406,946

which is a CON of 08/669,272 05/29/1996 PAT 5,742,074

** FOREIGN APPLICATIONS *****

yes K.N.

JAPAN 07-134400/1995 05/31/1995

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 29	TOTAL CLAIMS 40	INDEPENDENT CLAIMS 8
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>K. N. Burns</i>	Initials K.N.		

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TITLE

Thin film transistor matrix device and method for fabricating the same

☐ All Fees☐ 1.16 Fees (Filing)